1/15 Fig. 1 → X 9 1 9 2 4 101 33 3 4 000 600] 000 1000 -6 37 14 12--12 <u>्</u> G 10

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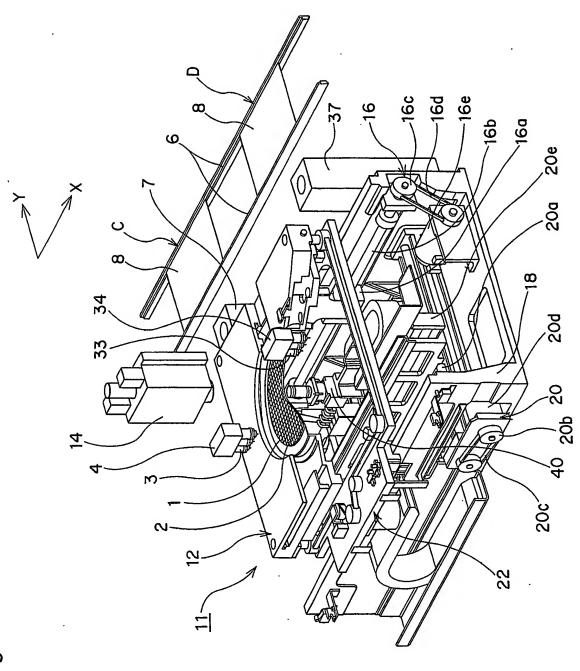
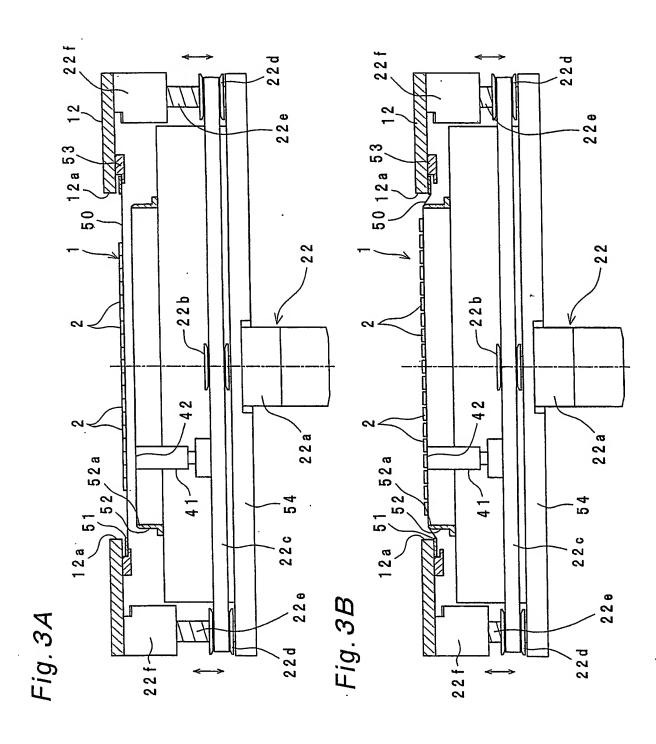
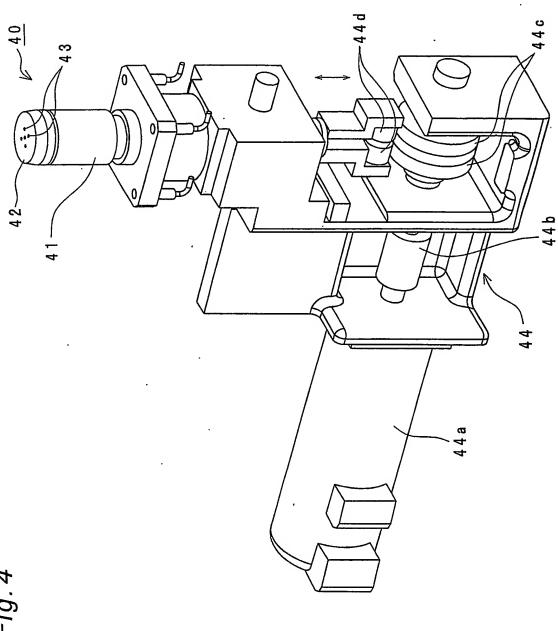


Fig.

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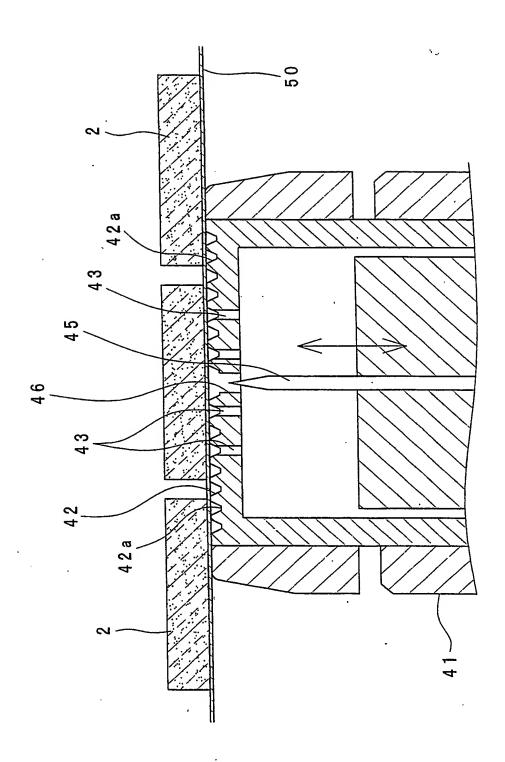


Fig. 5

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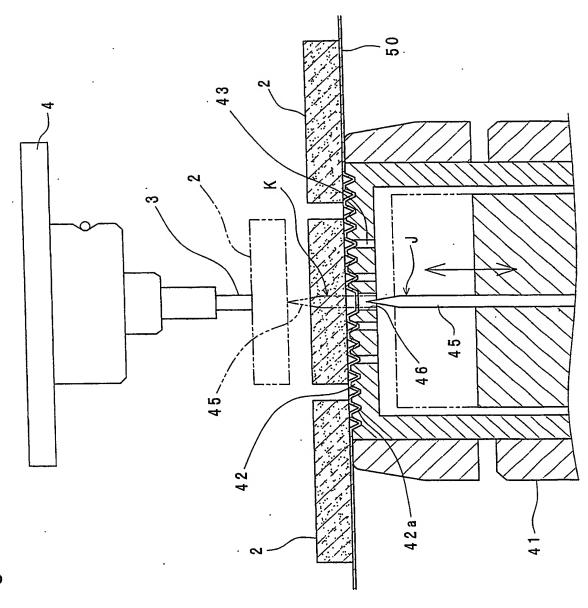
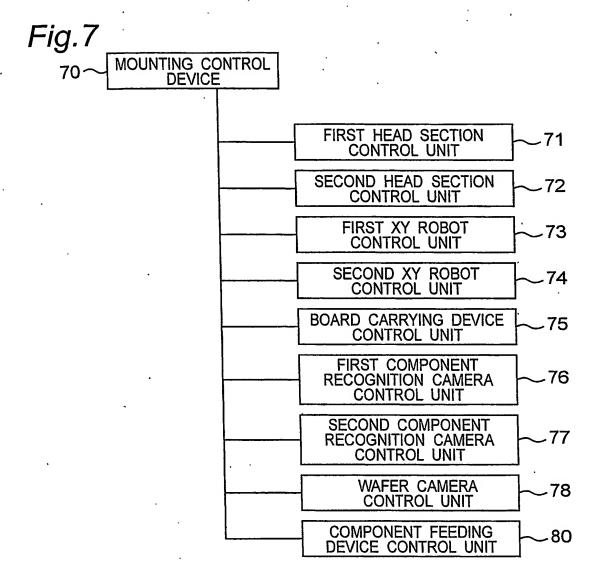
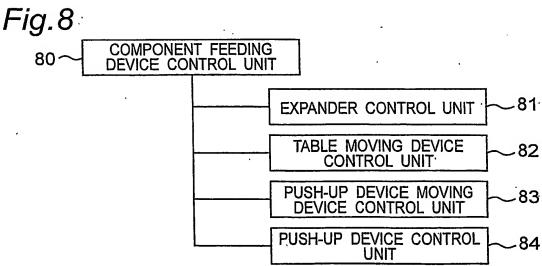
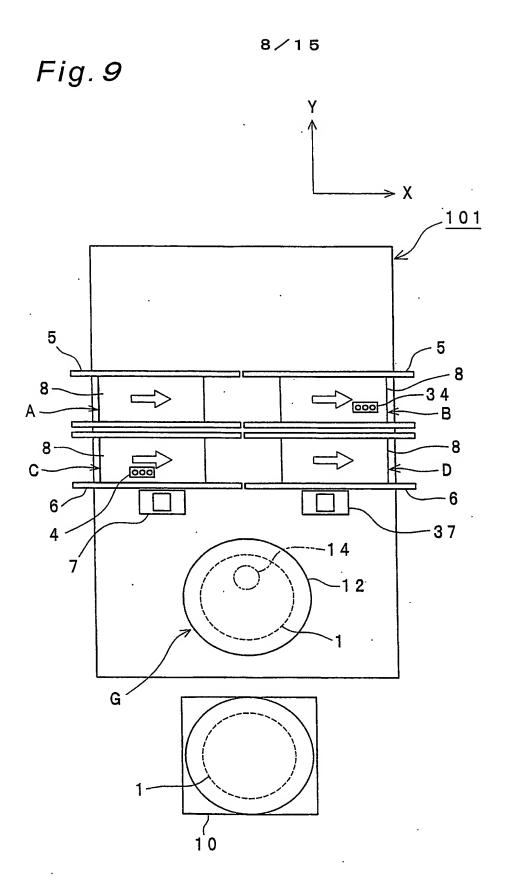


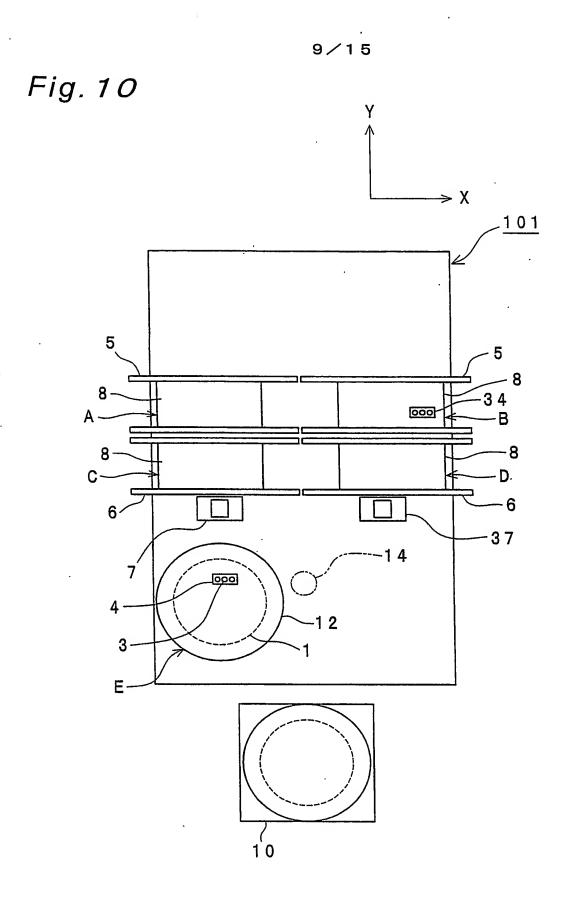
Fig. 6

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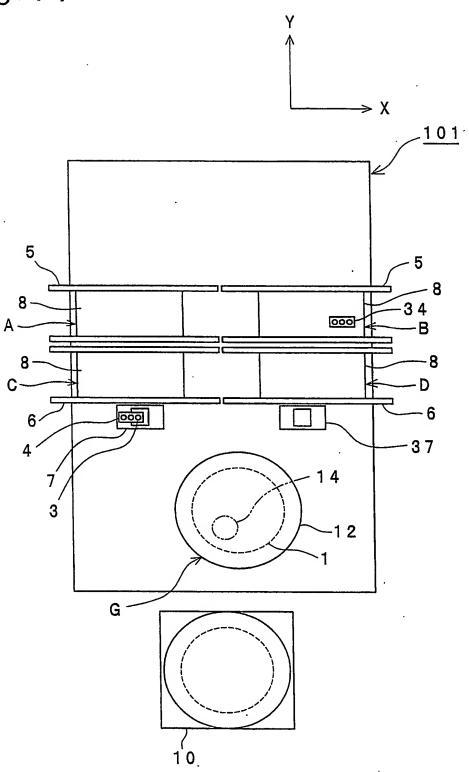






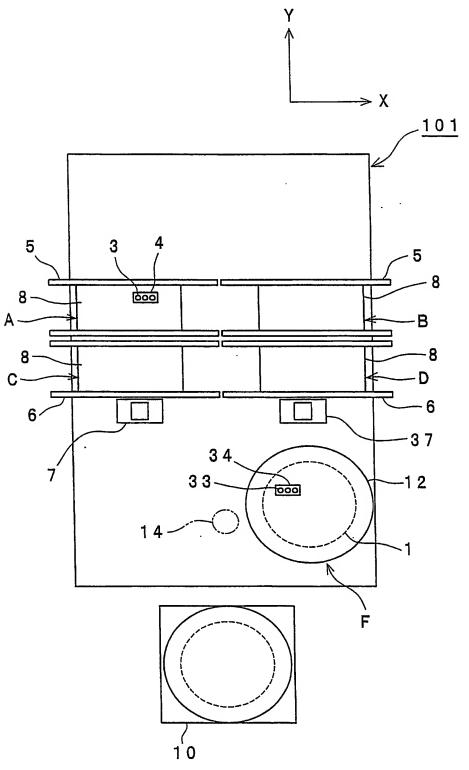
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Fig. 11



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Fig. 12



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Fig. 13

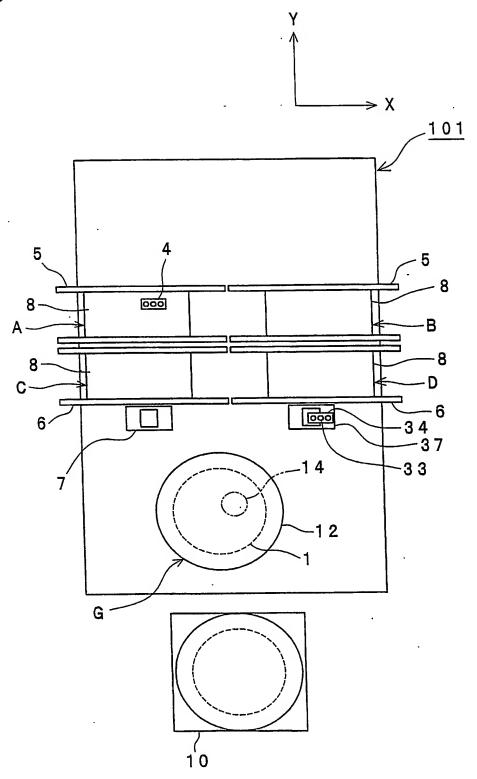
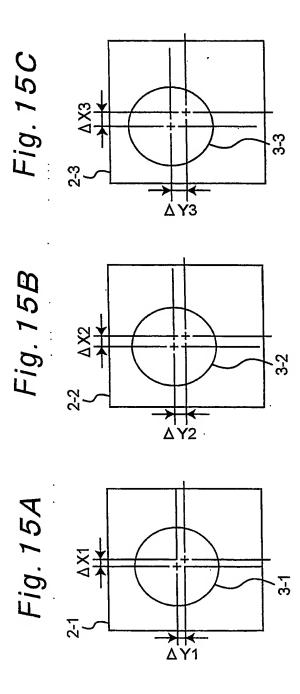


Fig. 14

13/15																
900ms		STOP		. 오		SUCTION ON			STOP				SUCTION ON		BLOW OFF	(TIME)
500ms				운동		冶						<u>+</u> >			-+	.T12
		MOVEMENT			<u>-</u>	SUCTION OFF	0		MOVEMENT				SUCTION OFF	 	BLOW ON	T10 T11
400ms		¥ ⊤				<u></u>			<u> </u>						ਜ਼ 	18 ¹
				至							- - -					T6 T7
300ms				뙤			$\prec /$								-	15
200ms		STOP		王		SUCTION ON			STOP		STOP		SUCTION ON		BLOW OFF	
100ms	21100			윤		병				-			넁			2 T37
c						SUCTION OFF			MOVEMENT		MOVEMENT		SUCTION OFF		BLOW	T0 T1T2
		HEAD SECTION XY MOVEMENT OPERATION MOVEMENT		SUCTION NOZZLE ELEVATING/LOWERING OPERATIONS		SUCTION OPERATION	PUSH-UP	PUSH-UP OPERATION		PUSH-UP DEVICE XY MOVEMENT OPERATION		HOLDING TABLE MOVEMENT OPERATION		SUCTION OPERATION WAFER SHEET SUCTION		BLOWING OPERATION T

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Fig.16

